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Nte: Acknowledgment
by smalls-loc
a-3-02

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OFFICE OF PUBLICATIONS

Hideki KOMATSUDA

Notice of Allowance

Mailed: August 19, 2002

Confirmation No.: 4482

Group Art Unit: 2851

Application No.: 09/697,639

Examiner: R. Fuller

Filed: October 27, 2000

Docket No.: 105193.01

For: EXPOSURE APPARATUS AND METHOD OF FABRICATING A MICRO DEVICE USING
THE EXPOSURE APPARATUS

**REQUEST FOR ACKNOWLEDGMENT OF
CONSIDERATION OF DISCLOSED INFORMATION**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

RECEIVED
AUG 26 2002
TECHNOLOGY CENTER 2800

Sir:

An Information Disclosure Statement with Form PTO-1449 was filed in the above-captioned patent application on October 27, 2000. Applicant received back from the Examiner a partially initialed copy of the Form PTO-1449. The Examiner is respectfully requested to initial adjacent to JP-A-60-232552, and return to Applicant to acknowledge the fact that the Examiner has considered all of the cited disclosed information. For the convenience of the Examiner, a copy of that form is attached.

Should there be any questions concerning this communication, please telephone the undersigned at the number set forth below.

Respectfully submitted,



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MAC/ccs

Date: August 26, 2002

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